

Electronic Patent Application Fee Transmittal

Application Number:	10792038			
Filing Date:	03-Mar-2004			
Title of Invention:		Composition and process for post-etch removal of photoresist and/or sacrificial anti-reflective material deposited on a substrate		
First Named Inventor:	Melissa K. Rath			
Filer:	Tristan Anne Fuerer/Lillian Glenn			
Attorney Docket Number:	ATMI-668			

Filed as Large Entity

Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Extension - 2 months with \$0 paid	1252	1	450	450
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				450